



PATENT APPLICATION
Attorney Docket No.: (SYP-060RECNY)

O. Lawrence
#23
3/30/03

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Marvin L. Vestal

Application No.: 09/755,951 Filed Date: January 4, 2001

Confirmation No.: 4499 Group: 1743 Examiner: A. Soderquist

For: Mass Spectrometer System and Method for Matrix-Assisted Laser Desorption Measurements

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Date: July 24, 2003 Express Mail Label No. ET81771343545

REPLY

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Sir:

This Reply and a Declaration Under 37 C.F.R. § 1.132 are being filed in response to the Office Action mailed from the U.S. Patent and Trademark Office on January 24, 2003, ("the Office Action") for the above-identified application. Consideration of the Declaration, and reconsideration and further examination are respectfully requested.

An extension to respond to the Office Action is respectfully requested. A Petition for Extension of Time to respond to the Office Action and the appropriate fee are being filed concurrently with this Reply. If any additional fees are due for this submission, the Director is hereby authorized to charge any required fees to Deposit Account No. 50-1935.